

Electronic Patent Application Fee Transmittal

Application Number:	10666331			
Filing Date:	17-Sep-2003			
Title of Invention:	Methods for cleaning a set of structures comprising yttrium oxide in a plasma processing system			
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Filer:	Joseph A. Nguyen/Cassandra Reynolds			
Attorney Docket Number:	LMRX-P023/P1130			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				810